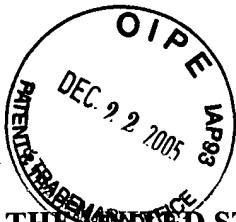


MICRON.230DV1



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

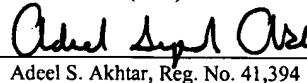
Applicant : Liu et al.
Appl. No. : 10/734,663
Filed : December 11, 2005
For : METHOD FOR MANUFACTURE
OF MAGNETO-RESISTIVE BIT
STRUCTURE
Examiner : Long K. Tran
Group Art Unit : 2818

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 20, 2005

(Date)


Adeel S. Akhtar, Reg. No. 41,394

AMENDMENT UNDER 37 C.F.R. 1.312

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The present amendment under 37 C.F.R. § 1.312 is filed after the issuance of the Notice of Allowance in connection with the above-identified patent application and with payment of the issue fee. Please amend the above-identified application as indicated below.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 4 of this paper. Replacement sheets are also attached to this paper.

Remarks/Arguments begin on page 5 of this paper.